INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 25, 2026

IGI Report Number	LG831659470
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MIXED CUT
Measurements	11.13 X 7.59 X 4.79 MM

GRADING RESULTS

Carat Weight	3.90 CARATS
Color Grade	E
Clarity Grade	VVS 2

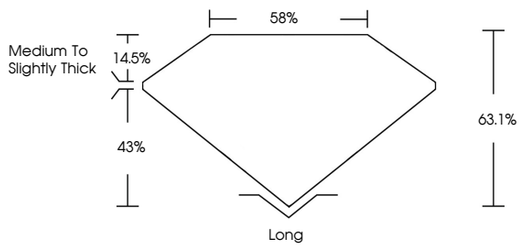
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG831659470

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG831659470
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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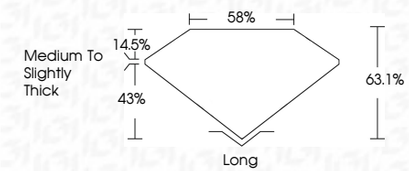

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IGI

August 25, 2026
IGI Report No LG831659470
CUT CORNERED RECT. MIXED CUT
11.13 X 7.59 X 4.79 MM
Carat Weight 3.90 CARATS
Color Grade E
Clarity Grade VVS 2
Depth 63.1%
Table 58%
Girdle Medium To Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG831659470
Comments:
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Type IIa